

Applicant Initiated Interview Request Form

Application No.: 69 914,928 First Named Applicant: Loick Verger Examiner: SUNG, Christine Art Unit: 2878 Status of Application: Ponding					
Tentative Participants: (1) Masako Ando (2)					
(3)					
Proposed Date of Interview: To be determined Proposed Time: 1:30 (AM/PM) EDT					
Type of Interview Requested: (1) Telephonic (2) Personal (3) Video Conference					
Exhibit To Be Shown or Demonstrated: MYES [] NO If yes, provide brief description: Response to Office Action fled herewith					
Issues To Be Discussed					
Issues (Rej., Obj., etc)	Claims/ Fig. #s	Prior Art	Discussed	Agreed	Not Agreed
(1) Rej. 103	Claim 1	Wei, Kobayashi	[]	[]	[]
(2)			[]	[]	[]
(3)			[]	[]	[]
(4)			[]	[]	[]
[] Continuation Sheet Attached					
Brief Description of Arguments to be Presented: Kologyashi does not teach the alledged modification.					
An interview was conducted on the above-identified application on					
NOTE: This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP § 713.01). This application will not be delayed from issue because of applicant's failure to submit a written record of this interview. Therefore, applicant is advised to file a statement of the substance of this interview (37 CFR 1.133(b)) as soon as possible.					
Brush and					
(Applicant/Applicant's Representative Signature) (Examiner/SPE Signature)					

This collection of information is required by 37 CFR 1.133. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 21 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE UNITED STATE PATENT AND TRADEMARK OFFICE

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Expires: August 10, 2006

Harry I. Moatz

Director of Enrollment and Discipline